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7/13/03
MachApplication No.: 09479,483
Docket No.: TKHR4580

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Application No.: 09/479,483 ✓

Filed: January 10, 2000 ✓

For: Fabrication Method for a Multi-Layered
Thin Film Protective Layer

Applicant: Chen et al.

Examiner: Fourson III, George R

Art Unit 2823

I hereby certify that this correspondence
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Alexandria, VA22313-1450, on

(Date)

No fee is believed to be due in connection with this amendment and response to Office Action. If, however, any fee is believed to be due, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. TKHR4580

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Sir:

In response to the Office Action dated May 8, 2003, please enter the following
amendments and consider the following remarks.